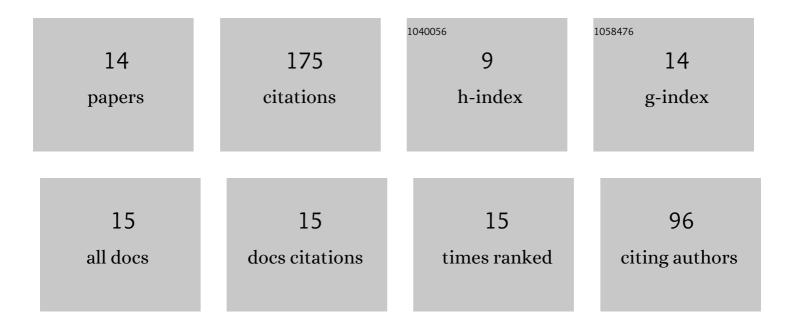
Hideyuki Yasufuku

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/287398/publications.pdf Version: 2024-02-01



#	Article	IF	CITATIONS
1	Versailles Project on Advanced Materials and Standards interlaboratory study on intensity calibration for x-ray photoelectron spectroscopy instruments using low-density polyethylene. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2020, 38, 063208.	2.1	21
2	On the wide-energy-range tuning of x-ray photoemission electron microscope optics for the observation of the photoelectrons excited by several keV x-rays. Review of Scientific Instruments, 2006, 77, 033702.	1.3	5
3	Development of Photoemission Electron Microscope by Imaging Inner Shell Photoelectrons Excited by High Energy Synchrotron Radiation X-rays. Hyomen Kagaku, 2005, 26, 524-531.	0.0	1
4	Observation of Element-Specific Energy-Filtered X-Ray Photoemission Electron Microscopy Images of Au on Ta Using a Wien Filter Type Energy Analyzer. Japanese Journal of Applied Physics, 2004, 43, 7682-7688.	1.5	11
5	Application of x-ray photoemission electron microscopy developed at SPring-8 BL15XU. Surface and Interface Analysis, 2004, 36, 892-895.	1.8	9
6	Observation of Energy-filtered Images and Energy Dispersive Images of Au/Ta Photoelectron by EXPEEM with a Wien Filter Type Energy Analyzer. Hyomen Kagaku, 2003, 24, 509-511.	0.0	4
7	Observation of Energy-Filtered Image for X-Ray Photoemission Electron Microscopy (EXPEEM) Using a Retarding Wien-Filter Energy Analyzer. Chemistry Letters, 2002, 31, 842-843.	1.3	13
8	Recent Development and Application of LEEM/PEEM. Observations of Ultra-thin Organic Films by MEEM and PEEM Hyomen Kagaku, 2002, 23, 292-299.	0.0	1
9	PEEM and MEEM of chloroaluminum phthalocyanine ultrathin film on MoS2. Journal of Electron Spectroscopy and Related Phenomena, 2001, 114-116, 1025-1030.	1.7	21
10	Surface Images of SiO2/Si(100) Pattern using Electron Emission Microscopy with Metastable Atoms, Photons and Low-Energy Electrons. Japanese Journal of Applied Physics, 2001, 40, 2447-2450.	1.5	14
11	Diffusion of chloroaluminum phthalocyanine on MoS2 surface detected by photoemission electron microscopy and metastable electron emission microscopy. Journal of Applied Physics, 2001, 90, 213-216.	2.5	16
12	Surface States of Hydrogen-terminated Si(111) by Metastable Atom Electron Spectroscopy and Angle-resolved Ultraviolet Photoelectron Spectroscopy. Japanese Journal of Applied Physics, 2000, 39, 1706-1709.	1.5	11
13	Reaction at the Outermost Surface Selectively Induced by Metastable-Atom Beams. Japanese Journal of Applied Physics, 2000, 39, 4126-4129.	1.5	14
14	Study of solid surfaces by metastable electron emission microscopy: Energy-filtered images and local electron spectra at the outermost surface layer of silicon oxide on Si(100). Journal of Applied Physics, 1997, 82, 2954-2960.	2.5	34